

Applicant : Kenichiro Kobayashi et al.
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In the Specification:

Please replace paragraph [0001] with the following amended paragraph.

This application is a continuation of U.S. Patent Application No. 09/838,905 filed on April 20, 2001 entitled METHOD AND APPARATUS TO MEASURE AMOUNT OF MOVEMENT USING GRANULAR SPECK PATTERN GENERATED BY REFLECTING LASER BEAM, now U.S. Patent No. U.S. Patent No. 6,847,910.